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Date

February 7, 2007

TO

: Director, Office of Patent Publication

FROM

Office of Petitions

SUBJECT

: Withdrawal from Issue of Application No. 10/611,918

Applicant(s)

: Takashi Igarashi et al

Application No.

: 10/611,918

Filed

: July 3, 2003

The above-identified application has been assigned Patent No. 7,179,153 and an issue date of February 20, 2007.

It is hereby directed that this application be withdrawn from issue at the request of the applicant. Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of February 20, 2007:

"All reference to Patent No. 7,179,153 to Takashi Igarashi et al of Japan for LENS MACHINING APPARATUS AND METHOD appearing in the Official Gazette of February 20, 2007 should be deleted since no patent was granted."

Petitions Examiner Office of Petitions

cc:

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